	Application No.	Applicant(s)
Notice of Allowability	40/044 449	NAKAGAWA ET AL.
	10/014,418 Examiner	Art Unit
		4700
	Matthew J. Song	1722
The MAILING DATE of this communication a claims being allowable, PROSECUTION ON THE MERITS ewith (or previously mailed), a Notice of Allowance (PTOL TICE OF ALLOWABILITY IS NOT A GRANT OF PATEN the Office or upon petition by the applicant. See 37 CFR 1	S IS (OR REMAINS) CLOSED in -85) or other appropriate commu T RIGHTS. This application is s	this application. If not included inication will be mailed in due course. THIS
\boxtimes This communication is responsive to <u>8/10/2005</u> .		
\boxtimes The allowed claim(s) is/are 9 and 35 .		•
Acknowledgment is made of a claim for foreign priorit a) □ All b) □ Some* c) □ None of the:		or (f).
1. Certified copies of the priority documents i		n No
 Certified copies of the priority documents I Copies of the certified copies of the priority 	• •	
International Bureau (PCT Rule 17.2(a)).	documents have been received	in this national stage application from the
* Certified copies not received:		
pplicant has THREE MONTHS FROM THE "MAILING DA' oted below. Failure to timely comply will result in ABANDO HIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requirements
A SUBSTITUTE OATH OR DECLARATION must be s INFORMAL PATENT APPLICATION (PTO-152) which		
CORRECTED DRAWINGS (as "replacement sheets")	must be submitted.	
(a) including changes required by the Notice of Drafts	person's Patent Drawing Reviev	(PTO-948) attached
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date	, 	
(b) including changes required by the attached Exami Paper No./Mail Date	ner's Amendment / Comment or	in the Office action of
Identifying indicia such as the application number (see 37 Cleach sheet. Replacement sheet(s) should be labeled as such		
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attached Examiner's comment regarding REQUIREME achment(s)	5. ☐ Notice of In 48) 6. ☐ Interview Si Paper No./ SB/08), 7. ☐ Examiner's	ımmary (PTO-413), Mail Date

U.S. Patent and Trademark Office PTOL-37 (Rev. 7-05)

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 8/10/2005 has been entered.

Allowable Subject Matter

- 2. Claims 9 and 35 are allowed.
- 3. The following is an examiner's statement of reasons for allowance: The closest prior art is Vehse (US 3,648,653) and Mada et al (JP 57-95893). The combination of Vehse and Mada et al teaches a process of liquid phase growth comprising immersing a plurality of substrates in a melt, growing a crystal on a surface of the substrate, rotating the crucible independently from the substrates, and the substrates are set aside from the center of rotation, wherein no part of the substrates is disposed at a center of rotation of the crucible, and the substrates are set upright. The combination of Vehse and Mada et al does not teach or suggest the plurality of substrates extends outwardly in a common radial direction from the axis of the center of rotation of the crucible, such that each of the plurality of substrates is set upright.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

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fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

4. Any inquiry concerning this communication or earlier communications from the examiner

should be directed to Matthew J. Song whose telephone number is 571-272-1468. The examiner

can normally be reached on M-F 9:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Duane Smith can be reached on 571-272-1166. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Matthew J Song

Examiner

Art Unit 1722

MJS October 28, 2005

> ROBERT KUNEMUND PRIMARY EXAMINER